#### New Emission Standards for the Refractory Products Manufacturing industry were promulgated on April 16, 2003

#### Who is covered by the rule? [§63.9782]

#### You are affected if:

- Your facility is a major source, is located at a major source, or is a part of a major source of hazardous air pollutants (HAP), AND
- You own or operate any of the following:
  - Thermal process sources of organic HAP; or • Kilns that are used to manufacture chromium or clay •
    - refractory products

#### Refractory products include...

Refractory bricks and shapes, kiln furniture, crucibles, refractory ceramic fiber, and other materials used as linings for boilers, kilns, and other processing units and equipment where extremes of temperature, corrosion, and abrasion would destroy other materials.

#### A thermal process source of organic HAP is any...

- · Shape dryer, curing oven, or kiln that is used to manufacture refractory products that use organic HAP, such as resin-bonded refractory products and pitchbonded refractory products; or
- Shape preheater, pitch working tank, defumer, or coking oven that is used to produce pitch-impregnated refractory products

Who is not covered by the rule? [§63.9782]

Most refractory products manufacturing facilities are not affected by this rule.

You are not affected if:

- Your facility is not a major source of HAP; OR
- You do not own or operate any refractory products thermal processing units, such as dryers, kilns, curing ovens, coking ovens, or defumers; OR
- You do not produce refractory products that \* are. . .
  - Dried, cured, or fired and contain organic HAP, such • as phenol, formaldehyde, or methanol.
  - Dried, cured, or fired and contain pitch or other material that releases organic HAP, or
  - Fired and contain at least 10% uncalcined clay, or •
  - Fired and contain at least 1% chromium.

| §63.9786] |
|-----------|
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| If the initial startup of your affected source is | Then your affected source is | And you must comply by                 |
|---|------------------------------|--|
| On or before June 20, 2002                        | An existing source           | April 17, 2006                         |
| Between June 20, 2002<br>and April 16, 2003       | A new source                 | April 16, 2003                         |
| After April 16, 2003                              | A new source                 | The initial startup date of the source |

#### What standards must I follow? [§63.9788]

Subpart SSSSS requires you to comply with:

\* Emission limits

- \* Operating limits and monitoring requirements
- \* Work practice standards
- \* Reporting and recordkeeping requirements

#### **Emission Limits** [§63.9788 and Table 1 of subpart SSSSS]

| If your affected source is a   | You must meet the following emission limit                | Or the following percent reduction limit |
|--|---|--|
| Thermal process<br>source of organic<br>HAP that is<br>equipped with a<br>control device                       | 20 ppmdv THC at<br>18% oxygen*                            | 95% THC                                  |
| Thermal process<br>source of organic<br>HAP that uses<br>process changes to<br>reduce organic HAP<br>emissions | 20 ppmdv THC at<br>18% oxygen*                            | No percent<br>reduction option           |
| Kiln that is not<br>equipped with a<br>control device  | 20 ppmdv THC at<br>18% oxygen*                            | No percent reduction option              |
| New clay refractory<br>products kiln   | For HF, 0.038<br>Ib/ton, AND<br>for HCl, 0.18<br>Ib/ton** | 90% HF, AND<br>30% HCI                   |

- corrected to 18 percent oxygen. \*\* Pounds of hydrogen fluoride or hydrochloric acid per ton of
- uncalcined clay processed.

#### **Operating Limits and Monitoring Requirements**

[§§63.9788, 63.9800, and Table 2 of subpart SSSSS]

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|--|--|--|--|--|--|--|
| Organic HAP Sources           If your affected source         You must monitor and meet the operating limit* for the                               |  |  |  |  |  |  |
| Thermal process<br>source of organic HAP<br>Thermal process  | ic HAP and maintain that rate<br>s The thermal oxidizer combustion   |  |  |  |  |  |
| source of organic HAP<br>equipped with a<br>thermal oxidizer   | chamber temperature  |  |  |  |  |  |
| Thermal process<br>source of organic HAP<br>equipped with a<br>catalytic oxidizer  | The temperature at the inlet to the catalyst bed   |  |  |  |  |  |
| Thermal process<br>source of organic HAP<br>equipped with another<br>type of control device  | <ul> <li>No operating limit, but you must<br/>install a THC CEMS** and<br/>comply with PS-8 (40 CFR 60,<br/>appendix B), and Procedure 1<br/>(40 CFR 60, appendix F); AND</li> <li>Submit a request for approval of<br/>alternative monitoring and<br/>comply with the requirements of<br/>the approved monitoring<br/>procedures</li> </ul> |  |  |  |  |  |
| Clay I   | Refractory Kilns   |  |  |  |  |  |
| New clay refractory<br>products kiln equipped<br>with a dry limestone<br>adsorber (DLA)  | <ul> <li>The pressure drop across the DLA</li> <li>The limestone feeder setting</li> <li>Maintain free-flowing limestone throughout the system;</li> <li>Use the same limestone grade and supply used during your most recent performance test.</li> </ul>   |  |  |  |  |  |
| New clay refractory<br>products kiln equipped<br>with a dry injection<br>fabric filter (DIFF) or<br>dry lime<br>scrubber/fabric filter<br>(DLS/FF) | <ul> <li>The lime feeder setting; AND</li> <li>Maintain free-flowing limestone<br/>throughout the system</li> </ul>  |  |  |  |  |  |
| New clay refractory<br>products kiln equipped<br>with a wet scrubber   | <ul> <li>The pressure drop across the scrubber</li> <li>If chemicals are added to the scrubber liquid, the chemical feed rate</li> </ul>   |  |  |  |  |  |

Based on the limit established during the most recent performance test.

\*\* Total hydrocarbon continuous emission monitoring system.

#### Work Practice Standards [§63.9788 and Table 3 of subpart SSSSS]

| If your<br>affected<br>source is  | You must perform the following work practices  |  |
|---|--|--|
| An existing<br>shape<br>preheater used<br>for making<br>pitch-<br>impregnated<br>refractory<br>products | <ul> <li>At least every 10 cycles, clean the holding baskets by abrasive blasting, or</li> <li>At least every 10 cycles, subject the holding baskets to a thermal process cycle that meets or exceeds the temperature and cycle time of the preheater and is exhausted to a thermal or catalytic oxidizer, or</li> <li>Exhaust emissions from the preheater to a control device that controls emissions from defumer or coking oven</li> </ul> |  |
| A pitch working tank  | <ul> <li>Exhaust emissions from the pitch<br/>working tank to a control device<br/>that controls emissions from<br/>defumer or coking oven, or</li> <li>Exhaust emissions from the tank<br/>to a comparable control device</li> </ul>  |  |
| A chromium<br>refractory<br>products kiln   | Use natural gas or equivalent fuel,<br>except during periods of natural gas<br>curtailment or supply interruption  |  |
| An existing<br>clay refractory<br>products kiln   | Use natural gas or equivalent fuel,<br>except during periods of natural gas<br>curtailment or supply interruption  |  |

## Notification, Recordkeeping, and Reporting Requirements

### Notifications

Initial Notification: [§§63.9(b) and 63.9812] The initial notification states that your facility is subject to the Refractory Products Manufacturing NESHAP. For existing sources, you must submit this notification by August 14, 2003; for new sources, you must submit the notification by August 14, 2003, or 120 days after the startup date, whichever is later.

#### Notification of Performance Test:

[§§63.7(b), 63.9(e), and 63.9812] If your facility is required to conduct performance tests, you must submit a notification of your intent to conduct a performance test 60 days prior to the test.

### Notification of Compliance Status:

[§§63.9(h) and 63.9812]

You must submit a Notification of Compliance Status to document your initial compliance within 60 days of your initial performance test.

## **Notification of Alternative Fuel Use**: [§63.9812(f)]

If you own or operate an affected clay or chromium refractory products kiln and you intend to use a fuel other than natural gas or equivalent to fire the kiln, you must submit a Notice of Alternative Fuel Use within 48 hours of the declaration of natural gas curtailment or supply interruption.

## **Reports and Record Keeping**

**Semiannual Compliance Reports**: [§63.9814] After the initial compliance period, each affected source must submit semiannual compliance reports.

#### Immediate Startup, Shutdown, and Malfunction Reports: [§63.10(d)]

You must submit an Immediate Startup, Shutdown, and Malfunction Report following any startup, shutdown, or malfunction of an affected source during the reporting period that was not consistent with your startup, shutdown, and malfunction plan.

## Report of Alternative Fuel Use: [§63.9814(g)]

If you own or operate an affected clay or chromium refractory products kiln and you use a fuel other than natural gas or equivalent to fire the kiln, you must submit a Report of Alternative Fuel Use within 10 working days after you stopped using the alternative fuel.

## Records: [§63.9816]

Your facility is required to keep records of reported information and all other information necessary to document compliance with the proposed rule for 5 years. Design and operation records for the control and monitoring equipment must be kept for the life of the equipment.

# Comprehensive Environmental Reporting System (CERTS)

The Office of Air Quality Planning and Standards is developing recommendations and options for electronic web-based reporting of environmental regulatory requirements and for direct reporting of data to EPA. As currently planned CERTS will allow facilities to report NESHAP compliance requirements through EPA's Central Data Exchange (CDX) system. You can access more information on CERTS at the following website: <u>http://www.epa.gov/ttn/atw/certs/</u> Copies of the rule and other material are located at EPA's Refractory Products Manufacturing Web site:

You can also contact your regional EPA air toxics office at the following numbers:

| Address   | States                                  | Website/<br>Phone Number               |
|---|---|--|
| Region 1<br>1 Congress Street<br>Suite 1100<br>Boston, MA 02114-2023                  | CT, MA,<br>ME, NH,<br>RI, VT            | www.epa.gov/region1<br>(888) 372-7341  |
| Region 2<br>290 Broadway<br>New York, NY 10007-1866                                   | NJ, NY,<br>PR                           | www.epa.gov/region2<br>(212) 637-3000  |
| Region 3<br>1650 Arch Street<br>Philadelphia, PA 19103-2029                           | DE, MD,<br>PA, VA,<br>WB, DC            | www.epa.gov/region3<br>(800) 438-2474  |
| Region 4<br>Atlanta Federal Center<br>61 Forsyth Street, SW<br>Atlanta, GA 30303-3104 | FL, NC,<br>SC, KY,<br>TN, GA,<br>AL, MS | www.epa.gov/region4<br>(800) 241-1754  |
| Region 5<br>77 W. Jackson Blvd<br>Chicago, IL 60604                                   | IL, IN,<br>MI, WI,<br>MN, OH            | www.epa.gov/region5<br>(800) 621-8431  |
| Region 6<br>1445 Ross Avenue<br>Suite 1200<br>Dallas, TX 75202                        | AR, LA,<br>NM,<br>OK, TX                | www.epa.gov/region6<br>(800) 887-6063  |
| Region 7<br>901 N. 5th Street<br>Kansas City, KS 66101                                | IA, KS,<br>MO, NE                       | www.epa.gov/region7<br>(800) 223-0425  |
| Region 8<br>999-18th St. Suite 300<br>Denver, CO 80202-2466                           | CO, MT,<br>ND, SD,<br>UT, WY            | www.epa.gov/region8<br>(800) 227-8917  |
| Region 9<br>75 Hawthorne St.,<br>San Francisco, CA 94105                              | CA, AZ,<br>HI, NV                       | www.epa.gov/region9<br>(415) 947-8000  |
| Region 10<br>1200 6th Avenue<br>Seattle, WA 98101                                     | ak, ID,<br>Wa, or                       | www.epa.gov/region10<br>(800) 424-4372 |

## Refractory Products Manufacturing NESHAP (Subpart SSSSS) An Overview of the Rule